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Cover: SEM images of Bi₂SiO₅ nanoflowers synthesized under the precursor at the temperature of 180 °C for 6 h. [W. Wei, J. Xie, S. Meng, X. Lü, Z. Yan, J. Zhu, and H. Cui: Synthetic bismuth silicate nanostructures: Photocatalysts grown from silica aerogels precursors. p. 1658].

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